

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shinji MAEKAWA et al.) Confirmation No. 3788
Application No. 10/575,492) Examiner: Stanetta D. Isaac
Filed: April 12, 2006) Group Art Unit: 2812
For: METHOD FOR FORMING WIRING, METHOD)
FOR MANUFACTURING THIN FILM) Date: <u>February 3, 2009</u>
TRANSISTOR AND DROPLET DISCHARGING)
METHOD)

INFORMATION DISCLOSURE STATEMENT

Mail Stop: RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return it to the undersigned.

The Commissioner is hereby authorized to charge the requisite \$180 fee in order to comply with the provisions of 37 C.F.R. § 1.97(c), and any other fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

NIXON PEABODY, LLP

Date: February 3, 2009

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